

Nanosize radiation defects in arsenic implanted HgCdTe epitaxial films of *n*- and *p*-type studied with TEM/HRTEM

***Izhnin I.I.*¹, *Mynbaev K.D.*², *Swiatek Z.*³, *Morgiel J.*³, *Korotaev A.G.*⁴,
*Voitsekhovskii A.V.*⁴, *Fitsych O.I.*⁵, *Varavin V.S.*⁶, *Dvoretzky S.A.*^{4,6},
*Mikhailov N.N.*⁶, *Yakushev M.V.*⁶, *Bonchuk O.Yu.*⁷, *Savytskyi H.V.*⁷**

¹ Scientific Research Company "Electron-Carat".
Stryjska St., 202, Lviv-79031, Ukraine.
E-mail: i.izhnin@carat.electron.ua

² Ioffe Institute.
Politekhnicheskaya St., 26, St. Petersburg-194021, Russia.

³ Institute of Metallurgy and Material Science PAN.
Reymonta St., 25, Krakow-30059, Poland.

⁴ National Research Tomsk State University.
Lenina Av., 36, Tomsk-634050, Russia.

⁵ P. Sagaidachny National Army Academy.
Gvardijska St. 32, Lviv-79012, Ukraine.

⁶ A.V. Rzhanov Institute of Semiconductor Physics, SB RAS.
ac. Lavrentieva Av., 13, Novosibirsk-630090, Russia.

⁷ Ya.S. Pidstryhach Institute for Applied Problems of Mechanics and Mathematics NASU. Naukova St., 3b, Lviv-79060, Ukraine.

We report on the results of comparative study of defect microstructure of molecular-beam epitaxy-grown epitaxial films of $\text{Hg}_{1-x}\text{Cd}_x\text{Te}$ ($x=0.22$) implanted with arsenic ions with 190 keV energy and 10^{14} cm^{-2} fluence. Two samples were studied: as-grown *n*-type sample and vacancy-doped *p*-type sample obtained with thermal annealing (220 °C, 24 h) at low mercury pressure in helium atmosphere. The microstructure observations were performed with transmission electron microscopy in bright field and high-resolution modes. It was found that after the implantation radiation-damaged area in two studied samples was identical and consisted of three characteristic layers, including a sub-surface layer with low defect density, a deeper layer with big dislocation loops and a deeply buried layer with small dislocation loops. Both the characteristic sizes of these regions and the types of radiation nano-defects were identical: dislocation loops, stacking faults, and crystal lattice disturbances. This confirms the conclusion that it is possible to study the electrical properties of radiation donor defects in *p*-type samples, since under real conditions in *n*-type samples they are masked by the high conductivity of the *n*-base.